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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4423**

Tomohiro OKUMURA et al. : Docket No. 2001-1089A

Serial No. 09/918,823 : Group Art Unit 2821

Filed August 1, 2001 : Examiner Tho Gia PHAN

PLASMA PROCESSING METHOD AND : **Mail Stop: AMENDMENT**
APPARATUS THEREOF

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of March 26, 2004, a Petition for a three-month extension of time being filed concurrently herewith, please amend the above-identified application as follows.